



35.C14023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAMAKI KOBAYASHI, ET AL.) : Examiner: Not Yet Assigned
Application No.: 09/440,535) : Group Art Unit: 2879
Filed: November 16, 1999) :
For: SUBSTRATE FOR ELECTRON) :
SOURCE, ELECTRON SOURCE :
AND IMAGE FORMING) :
APPARATUS, AND MANU- :
FACTURING METHOD THEREOF) April 23, 2001

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
35 U.S.C. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The listed documents were cited in a European
Search Report dated March 1, 2001 (copy enclosed) issued by a
foreign patent office in a counterpart foreign application.

The documents EP 0 865 931, JP 07 331450, and JP 60
015644, listed in the European Search Report, are not listed
on the attached Form PTO-1449, and are not submitted
herewith, since they were previously cited in an Information

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Disclosure Statement filed on May 11, 2000 in this application.

For the concise explanation of relevance for the non-English documents, the Examiner is respectfully referred to the English Abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 28,496

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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